

#8 reconsideration
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0941.65074

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application)

Applicant: Chikayoshi Kamata)

Serial No. 09/748,919)

Filed: December 27, 2000)

For: GIANT MAGNETO-
RESISTIVE DEVICE AND
A FABRICATION PROCESS
THEREOF)

Art Unit: 2652)

Examiner: Nguyen, D.)

I hereby certify that this paper is being deposited with the
United States Postal Service as FIRST-CLASS mail in an
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Washington, D.C. 20231, on this date.

1 Oct 02
Date F-CLASS.WCM Registration No. 29367
Appr. February 20, 1998 Attorney for Applicant

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Technology Center 2600

AMENDMENT A

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

In response to the office action mailed June 19, 2002, please consider the
following remarks.

REMARKS

Claim 1 stands rejected under § 102 on the basis of Chen et al. Applicant
respectfully traverses this rejection for the following reasons.

It is the object of the present invention to provide an overlay type MR sensor
with minimized oxidation of the cap layer covering the MR structure, by providing an